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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP ART UNIT 1765
PATENT

Customer No. 22,852
Attorney Docket No. 07553.0020-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takeshi SAITO et al.) Group Art Unit: 1765
Application No.: 09/807,896) Examiner: S. Ahmed
Filed: April 19, 2001)
For: PLASMA ETCHING METHOD) **Mail Stop AF**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed September 24, 2003, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Please amend claims 1 and 12 as set forth in the Amendments to the Claims section of this Amendment After Final.

The **Amendments to the Claims** section begins on page 2 of this Amendment After Final.

Remarks begin on page 4 of this Amendment After Final.

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